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Reversible Switching of Interlayer Exchange Coupling through Atomically-thin VO$_2$ via Electronic State Modulation

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Summary

Modulation of electronic properties in spintronic interfaces (spinterfaces) can give rise to the optimization and even emergence of abundant spintronic effects. However, a proof-of-concept demonstration of such a strategy has rarely been achieved. In this paper, we study the interlayer exchange coupling effect in a synthetic magnetic multilayer system $[\text{Pt/Co}]_2/\text{VO}_2/[\text{Co/Pt}]_2$, where atomically-thin phase change material VO$_2$ is adopted as a spinterface with reversible metal-to-insulator transition. Repeatable switching from antiferromagnetic coupling through insulating spinterface to ferromagnetic coupling through metallic spinterface is observed in this multilayer system. Further analyses indicate that such an evolution originates from two distinct coupling mechanisms of spin dependent tunneling and Rudermann–Kittel–Kasuya–Yosida interaction determined by the electronic states of VO$_2$. As an experimental demonstration of VO$_2$-tailored interlayer exchange coupling effect, this work highlights the great potential of spinterface as a magic building block in beyond-CMOS electronic devices.

Keywords: spinterface; phase change; interlayer exchange coupling; vanadium dioxide; spintronics
Introduction

Using electron spin states as quantum information carriers opens a broad avenue for storage, sensing and computing, known as the spintronics\(^1\). The spintronic property of a heterostructure is not only determined by the ferromagnetic electrodes via spin-dependent scattering, but also influenced remarkably by the spintronic interface (spinterface)\(^2\)–\(^4\), which tailors the physical process of spin filtering\(^5\), hot-electron transport\(^6\), spin torques\(^7\)–\(^10\) and interfacial Dzyaloshinskii-Moriya interaction\(^11,12\) etc. Previous studies reveal that the electronic property engineering of spinterfaces can become an effective strategy to extraordinarily optimize these physical effects and turn them into practical applications\(^10,12\). In this regard, spinterfaces with dramatically changeable electronic properties can be a magic building block for beyond-CMOS electronics.

As a representative effect of spinterface-tailored physical effects, interlayer exchange coupling (IEC) describes indirect interactions between magnetic layers through an atomically-thin spacer\(^3,10,13\). The coupling type, e.g., ferromagnetic (FM) or antiferromagnetic (AFM), reflects the band structure of the spacer around the Fermi surface\(^14\)–\(^16\). For IEC through metallic spacers, the periodic oscillation and fast decay of coupling strength with the spacer thickness\(^17\) have been explained by Rudermann–Kittel–Kasuya–Yosida (RKKY) theory\(^18\), which originates from interactions between localized d- or f-orbit electrons via the conduction electrons. Meanwhile, theories such as variable-range hopping and resonant tunneling through defect-generated localized electronic states in the gap of barrier have been developed to explain the exchange coupling through semiconducting spacers\(^19,20\). For insulating spacers, IEC with appreciable
strength and absence of oscillation has been interpreted by the spin dependent tunneling\textsuperscript{21,22}.
Pioneering theoretical studies have also been performed to develop a unified theory for different
kinds of spacers by introducing the concept of a complex Fermi surface\textsuperscript{23}. Thus, IEC through
spacers with controllable electronic properties, such as phase change materials\textsuperscript{24}, can be a good
choice to demonstrate the extraordinary control of physical effects tailored by the spinterface.

In this work, we study the IEC evolution through an atomically-thin VO\textsubscript{2} spacer, which features
a metal-insulator transition during the phase change\textsuperscript{25,26}. Magnetic heterostructure samples of
[Pt/Co\textsubscript{2}]/VO\textsubscript{2}/[Co/Pt\textsubscript{2}] with perpendicular magnetic anisotropy (PMA) are prepared by magnetron
sputtering under high vacuum to explore the electronic state induced regulation on the IEC.
Reversible switching between AFM coupling through insulating VO\textsubscript{2} and FM coupling through
metallic VO\textsubscript{2} is observed. The IEC regulation behavior is further explained by the effect of band
structure change in VO\textsubscript{2}, where the coupling mechanism changes from spin dependent tunneling
to RKKY interaction. Such an \textit{in-situ} IEC control may give rise to extended tunability of many
magnetic devices, such as magnetic random-access memory, highly sensitive magnetic sensors
and spin torque nano-oscillators, which is potential for function innovations of them. In addition
to extending the platforms for \textit{in-situ} IEC control, this work, based on electronic state modulations
of the VO\textsubscript{2} spinterface, may provide a widely-applicable, all-solid and multiply triggered solution
to optimize spintronic effects and implement device functions\textsuperscript{27}.

\textbf{Results}

\textit{Atomically-thin VO\textsubscript{2} films and phase change magnetic heterostructures}
The indirect coupling nature of IEC features a fast decay of the coupling strength with the spacer thickness, which usually confines the critical thickness of the spacer below several nanometers\textsuperscript{17}. For experimental explorations of electronic state induced IEC regulation, the preparation of atomically-thin VO\textsubscript{2} films is thus a fundamental problem. Although many methods have been developed to deposit VO\textsubscript{2}, such as molecular beam epitaxy\textsuperscript{28}, pulsed laser deposition\textsuperscript{29} and chemical vapor deposition\textsuperscript{30}, strict growth conditions, e.g., specific substrates, high temperature and high oxygen pressure, limit their applications in spintronics\textsuperscript{25}. A deposition method with abilities of nanometer-accuracy, heterostructure integration and interface engineering is thus desired.

In this work, magnetron sputtering is chosen as the deposition method of VO\textsubscript{2} and relevant magnetic heterostructures. Through a careful optimization of the deposition conditions, atomically-thin VO\textsubscript{2} films with nanometer thicknesses can be successfully prepared under high vacuum at room temperature. A broad peak has been found in the X-ray diffraction (XRD) result, indicating their amorphous feature (see Supplementary Figure S1). X-ray photoelectron spectroscopy (XPS) measurement is applied to check the valence state of vanadium. As shown in Figure 1A, the proportion of VO\textsubscript{2} reaches 97%, which demonstrates the relatively pure composition. The I-V curves with increasing temperature of a vertical tunnel junction device fabricated based on Au/VO\textsubscript{2} (2 nm)/Au heterostructure are shown in Figure 1B, from which an evolution from a tunneling contact to a transparent contact can be detected. The results indicate the dramatic change of the electronic property (\textit{i.e.}, an insulator to metal transition) in the VO\textsubscript{2}
spacer when the thermally triggered phase change occurs. Similar transport measurements of tunnel junctions with varied VO$_2$ thickness can be found in Figure S2. Figure 1C presents the ratio of the resistance change (calculated as the resistance divided by its minimum value) versus temperature with a measured current of 10 nA for a 2-nm-thick sample and a 40-nm-thick single-crystal film sample. It is noteworthy that the metal-insulator transition in the atomically-thin VO$_2$ layer occurs at a temperature much lower than that of the bulk sample. This difference is probably caused by the effect of interfacial strain, interfacial bonds or defects$^{25}$. Although potential factors such as the amorphous nature and inevitable defects still affect the resistance change amplitude (~20 times), the hysteresis phenomenon proves the existence of the metal-insulator transition in the atomically-thin film.

The appreciable metal-insulator transition, good compatibility of the substrates and high vacuum room-temperature deposition conditions of the atomically-thin VO$_2$ film further enable the fabrication of VO$_2$-based magnetic heterostructures. To investigate the effect of spinterface-tailored IEC, we prepare a series of [Pt/Co]$_2$/VO$_2$/[Co/Pt]$_2$ heterostructures (see Figure 1D for a schematic diagram). VO$_2$ layers with different thickness are adopted as the spacers, and Co/Pt systems are chosen as the FM layers with PMA. Distinct interfaces between multilayers are verified by high-resolution transmission electron microscopy (HRTEM, see Figure 1E), by which the thicknesses of the atomically-thin VO$_2$ spacers are calibrated to be 0.76, 1.48, 1.83 and 2.26 nm (see Figure S3). Some regions with microcrystalline morphology can also be observed within the VO$_2$ layer, which may be caused by the fluctuations of the sputtering energy and non-
annealing process. These inevitable defects can explain the sluggish metal-insulator transition curve and non-uniform phase change process mentioned in the following discussion. In the VO₂-based magnetic heterostructures, the magnetic electrons in the top and bottom layers are coupled indirectly through atomically-thin VO₂, whose electron density of 3d orbitals varies tremendously during the metal-insulator transition. Considering the process of electron reflections between the two electrodes in the spacer, this variation not only influences the transport efficiency which alters the magnitude of the electron wave, but also changes the phase shift during the reflecting. As a result, the quantum well states of the system will be altered, which determines the energy favorable coupling state\textsuperscript{23}. An unrevealed evolution of the IEC can thus be expected owing to the dramatic change in the VO₂ spinterface (Figure 1F).

**Electronic state induced IEC regulation**

The IEC regulation in the phase change magnetic heterostructures is firstly investigated by magnetic property measurements. A vibrating sample magnetometer (VSM) is used to characterize the [Pt/Co]\textsubscript{2}/VO₂/[Co/Pt]\textsubscript{2} samples. As shown in Figure 2A, strong anisotropy is detected in the sample with a 0.76-nm-thick VO₂ spacer. Similar PMA properties can be found in all the other films (see Figure S4). The magnetization shows two reorientation processes depending on the magnetic field, which indicates strong FM coupling within both the top and bottom Co/Pt bilayers. Thus, these bilayers will be treated as two single FM units when investigating the spinterface-tailored IEC effect.
As illustrated in Figures 2B-2E, hysteresis loops are also measured by the polar magneto-optic Kerr microscope (p-MOKE) before and after the metal-insulator transition for samples with different thickness of VO$_2$. Interestingly, the two magnetization flips merge into one after the VO$_2$ spacer change to be conducting for the 0.76-, 1.48-, 1.83- and 2.26-nm-thick VO$_2$ spacer samples. The experimental results of the control samples (with the structure of [Pt/Co]$_2$/VO$_2$ and VO$_2$/[Co/Pt]$_2$, Figure S5) show that the magnetization reorientation fields of the two Co/Pt bilayers are always different during the metal-insulator transition. Additionally, the phase change magnetic heterostructure shows no indication of anisotropy change, as the in-plane hysteresis loops coincide with each other during the metal-insulator transition (Figure 2F and Figure S6).

These features thus exclude the possibility that the regulation is caused by the differentiated PMA modulation effect on the top and bottom magnetic layers, and especially confirm the appearance of strong FM coupling between top and bottom Co/Pt bilayers when the atomically-thin VO$_2$ spacer becomes metallic.

To further understand this IEC regulation via dynamic modulation of the electronic states in VO$_2$ spacer, one key issue is to distinguish the coupling state of the [Pt/Co]$_2$/VO$_2$/[Co/Pt]$_2$ samples when VO$_2$ is insulating. Taking the sample with 0.76-nm-thick VO$_2$ as an example, a high-accuracy VSM with a built-in Hall probe (detecting accuracy of 0.01 Oe) is applied to collect the minor loop of the top magnetic layer. As shown in Figure 3A, a positive exchange bias $H_{ex-top}$ (~0.35 Oe) can be detected in multiple measurements at room temperature. Further result shows that the value increases to 0.64 Oe when temperature is decreased to 200K, indicating the
existence of an AFM coupling through insulating VO$_2$. To further confirm this result, the magnetic domain switching behavior around the field region of the minor loop is also investigated, as shown in Figure 3B. The results verify that the domain switching of the top magnetic layer happens near -0.2 Oe and 1.88 Oe, also giving a positive value of $H_{\text{ex-top}}$. Meanwhile, similar minor loop measurements are carried out for other samples (see Figure S7), which suggest that the samples with 1.48-, 1.83-, and 2.26-nm-thick VO$_2$ also exhibit AFM coupling for insulating VO$_2$ ($H_{\text{ex-top}}=0.57$, 0.56 and 0.59 Oe, respectively). However, when the thickness of VO$_2$ spacer is greater than 3 nm, the sample exhibits a decoupling feature ($H_{\text{ex-top}}\approx0.00$ Oe), which meets the fast decay feature of IEC. The dipolar effect, caused by the stray field of FM layers around the rough interfaces, can also result in 'fake' coupling. However, the HRTEM evidence of perfectly smooth interfaces (see Supplementary Figure S3E) indicates neglectable influence of this effect.

To obtain more details about the regulation effect, we then focus on the evolution of the IEC during the dynamic metal-insulator transition of VO$_2$ triggered by temperature control. Figure 3C shows the hysteresis loops of the samples at different temperatures. In all the four samples, there are double flips in the loops with insulating VO$_2$. As the electronic property changing from insulator to metal occurs, the loops feature a smooth flip of the top FM layer before a sudden transition into one single flip (that is, strong FM coupling). Interestingly, the critical temperature of the change in the IEC type shows a clear dependence on the VO$_2$ thickness. For the two thinner samples (0.76 nm and 1.48 nm), FM coupling appears around 320 K, while for the two
thicker samples (1.83 nm and 2.26 nm), the FM coupling change occurs at a slightly lower temperature (approximately 310 K). Considering the similar deposition parameters of all samples, one possible reason for this difference is the appreciable interfacial strain effect on the metal-insulator transition temperature of the atomically-thin VO$_2$\textsuperscript{25}. Considering that the VO$_2$ exhibits obvious hysteresis of metal-insulator transition (Figure 1C), the electronic state induced IEC regulation should exhibit the same feature. Therefore, we measure the magnetic loops of the 0.76-nm-thick VO$_2$ sample at two temperatures within the hysteresis range (305 and 315 K) during insulator to metal and metal to insulator transition processes (i.e., heating-up and cooling-down). As shown in Figure 3D, the sharpness of the flip in both results shows a clear difference, which proves our speculation and further verifies the origin of the IEC regulation as the metal-insulator transition of VO$_2$. Further measurements (see Figure S8) indicate the excellent repeatability of the AFM-to-FM coupling transition in these samples.

Based on the results obtained from all VO$_2$-based magnetic heterostructures, the exchange bias between two FM layers can be derived from the center shift of minor loops (for example the $H_{ex-top}$ in Figure 3A) or the shift of the flip edges relative to those of control samples\textsuperscript{31}. Considering the canted shape of the minor loops at high temperatures, we use the difference between the flip edge of the bottom FM layer (Figure 3C) and the coercive field of VO$_2$/[Co/Pt]$_2$ control sample (Figure S9) to calculate the value of exchange bias field $H_{ex-bottom}$. There are also some reports about the presence of AFM ordering with insulating VO$_2$\textsuperscript{32}. The calculation rule can thus eliminate this influence in the process of mutual subtraction. As plotted in Figure 4A, the negative $H_{ex-bottom}$
bottom values represent AFM coupling, and the positive represent FM coupling. Samples with various thickness of VO$_2$ (0.76, 1.48, 1.83 and 2.26 nm) all demonstrate a transition from appreciable AFM coupling through insulating VO$_2$ spinterface to stronger FM coupling through metallic VO$_2$ spinterface.

**Physical origin of the electronic state induced IEC regulation**

Considering the complexity of the spinterface, the mechanism behind the regulation can be a combined result of various effects, including the variation in electronic state, interfacial strain, Co-O bonds and interface defects etc. during the phase change. However, as the VO$_2$ layer is amorphous, it is hard to form a uniform strain to have a long-range effect on the exchange coupling. For Co-O bonds or interface defects, the affected atoms are usually confined around the interface limited in a few angstroms,\textsuperscript{33,34} which is far thinner than the Co/Pt bilayer thickness. Additionally, the magnetic anisotropy which is sensitive to these influences remains unchanged in the regulation process (Figure 2F), which indicates that they are not the major determinants. Since the IEC change shows a high correlation with phase change of VO$_2$ (Figure 3C & 3D), it is more convincing to attribute such a reversible coupling change to electronic state modulations of VO$_2$.

To understand the possible mechanism, the phase change of VO$_2$ should be taken into consideration. As pointed out by Goodenough, the Peierl-like phase change of VO$_2$ can produce a large spectral weight transfer from $\pi^*$ ($d_{xy}$) orbitals into the valence $d_{\|}$ ($d_{xz, yz}$) orbitals and
eliminate the band gap\textsuperscript{32,35}. The distinct electronic states of VO\textsubscript{2} can thus cause different IEC origins and behaviors. To clarify the physical mechanism of IEC through insulating and metallic VO\textsubscript{2} spinterface, the dependence of the coupling strength on VO\textsubscript{2} thickness at 200 and 360 K is shown in Figure 4B. The experimental values of coupling strength $J_{\text{exp}}$ are determined from the exchange bias field $H_{\text{ex-bottom}}$ using the relation\textsuperscript{31},

\[
J_{\text{exp}} = H_{\text{ex-bottom}} \left( \frac{M_{S1} t_1 M_{S2} t_2}{M_{S1} + M_{S2}} \right),
\]

(Equation 1)

where $t_1$ (0.9 nm) and $t_2$ (2 nm) represent the thicknesses of Co layers in the top and bottom magnetic layers, respectively, and $M_{S1}$ and $M_{S2}$ are their saturation magnetizations.

For IEC via insulating VO\textsubscript{2} spinterface, the rapid decay of the coupling strength with thicker spacer is consistent with the trend observed in oxide–based synthetic antiferromagnets\textsuperscript{21}. Considering the tunneling feature in the transport measurement of Au/VO\textsubscript{2}/Au junctions (Figure 1B & Figure S2), spin dependent tunneling, as suggested for the Co/MgO/Co system\textsuperscript{36}, which also features an exponential coupling strength decay, should dominate IEC in this case. The coupling strength then can be calculated as\textsuperscript{22}:

\[
J_{\text{cal}} = \frac{(U - E_F)}{8\pi^2 d^2} \frac{8k^3}{(k^2 + k_\uparrow^2)(k^2 + k_\downarrow^2)} e^{-2k d}\]

(Equation 2)

Where $J_{\text{cal}}$ is the calculated coupling strength, $(U - E_F)$ gives the barrier height of the heterostructure, $k_\uparrow$, $k_\downarrow$ is the Fermi wave vectors for the spin up and down bands of the FM layers, $d$ is the thickness of the insulating spacer, and $k$ is the wave vectors of electrons in the insulating layer,
A barrier height value of 1 eV, referring to the work function of VO\textsubscript{2} and Co\textsuperscript{37}, and an effective electron mass $m_{\text{eff}}=1\ m_e$\textsuperscript{38}, are adopted to perform the fitting of $J_{\text{cal}}$ in Figure 4B, which perfectly coincides with the experimental results of IEC through insulating VO\textsubscript{2} (at 200 K). Notably, the coupling strength shows a comparable value at AFM state to that of the FM state. According to previous research\textsuperscript{39}, localized states within the band gap induced by defects can enhance the coupling by spin dependent tunneling, and feature a strength decrease with temperature rising. Such an interpretation is consistent with the amorphous feature of the atomically-thin VO\textsubscript{2} films (Figure 1E) and the temperature dependence of the exchange field at AFM state (Figure 4A).

For the FM coupling via metallic VO\textsubscript{2} spinterface, the most widely accepted coupling mechanism is RKKY interaction. The coupling strength then can be calculated as\textsuperscript{40}:

$$J_{\text{cal}} \approx \frac{9\pi\delta^2\upsilon^2 F(\xi)}{64E_F},$$

(Equation 4)

where $\delta$ is the coupling constant, $\upsilon$ is the number of conduction electrons per atom, $E_F$ is the Fermi energy and $F(\xi)$ is the RKKY function\textsuperscript{40}

$$F(\xi) = (\sin \xi - \xi \cos \xi) / \xi^4,$$

(Equation 5)

where $\xi=2kFd$. The Fermi wavevector of free electrons $k_F$ is fitted to be $1.4\times10^7$ m\textsuperscript{-1} in the case of metallic VO\textsubscript{2} at 350 K. It appears clearly in Figure 4B that the experimental variation of the coupling strength with the metallic VO\textsubscript{2} spacer is well fitted with the framework of the RKKY model. Following the RKKY mechanism, the IEC through metallic VO\textsubscript{2} has a characteristic
feature of an extremely large oscillation period (up to hundreds of nanometers, see Inset of Figure 4B). As an example, an FM coupling of 37 μerg/cm³ can still be detected through a metallic VO₂ when its thickness reaches 3.22 nm. However, the coupling of this sample with insulating VO₂ is almost undetectable.

Besides the AFM to FM transition, the IEC evolution in our results accompanied by the smoothing of the first magnetization flip is different from a mere flip approaching behavior in a uniform IEC change route (Figure 4C). It can be explained by the inhomogeneous feature of the amorphous atomically-thin VO₂ film, which could induce domains with different conductivity and thus non-uniform coupling during the metal-insulator transition. This speculation is confirmed by the Kerr microscope of the domain at critical switching state during the insulator to metal transition, which first evolves into a maze morphology, then finely breaks into smaller size beyond the resolution of the microscope (Figure 4D). With the in-plane loop measurement excluding the possibility of an anisotropy change (Figure 2F and Figure S6), it is reasonable to believe that this change is caused by the non-uniform phase change of VO₂ providing more nucleation points for spin switching.

Discussion

Overall, the IEC regulation in this work has been verified to get tailored by the electronic state of the VO₂ spinterface. Compared to the modulation based on strain or ion migration, such a pure electronic effect features the potential advantages of high stability, low power consumption,
high speed (if with photonic excitation strategy\textsuperscript{43}) and all-solid structure. Such a VO\textsubscript{2} based spinterface, with appreciable metal-insulator transition that can be induced by methods such as thermal heating\textsuperscript{25}, electrical gating\textsuperscript{25}, and especially pulse laser excitation\textsuperscript{43}, would be a magic building block for spinterface-tailored physical effects and device applications. As the spinterface plays an important role in abundant physical processes, in addition to IEC, it is reasonable to believe that such a modulation method can be used to control other spin electronic structures or magnetic materials, such as skyrmion, 2D ferromagnets and ferromagnetic insulators. After proving the close relationship between IEC and interlayer electronic state by this work, further realization of phase change by electrical methods will give birth to even richer applications in spintronics.

**Conclusion**

In conclusion, atomically-thin VO\textsubscript{2} has been adopted as a spinterface with dramatically changeable electronic properties to regulate the interlayer exchange coupling effect. Both the coupling strength and the type (that is, antiferromagnetic and ferromagnetic coupling) of the magnetic heterostructures [Pt/Co\textsubscript{2}]/VO\textsubscript{2}/[Co/Pt\textsubscript{2}] can be tailored reversibly and repeatably through the metal-insulator transition of VO\textsubscript{2}. Further analyses indicate that such an evolution originates from two distinct physical mechanisms of spin dependent tunneling and RKKY interaction determined by the electronic states of VO\textsubscript{2}. As a proof-of-concept demonstration of interface-tailored spintronics, this work might provide a general strategy for beyond-CMOS electronics.
Experimental Procedures

Resource Availability:

Lead Contact: Further information and requests for resources and reagents should be directed to and will be fulfilled by the Lead Contact, Weisheng Zhao (weisheng.zhao@buaa.edu.cn).

Materials Availability: This study did not generate new unique reagents.

Data and Code Availability: Data supporting the findings of this manuscript are available from the corresponding authors upon reasonable request. A reporting summary for this article is available as a Supplemental Information file.

Film deposition and device fabrication: The Au/VO$_2$/Au and [Pt/Co]$_2$/VO$_2$/[Co/Pt]$_2$ heterostructures were both grown on SiO$_2$/Si substrates by magnetron sputtering at room temperature under high vacuum. A stoichiometric target was used to deposit the VO$_2$ film during the experiments. The tunnel junctions were patterned by optical lithography (Micro Writer ML Baby, Durham Magneto Optics) followed by argon ion-beam etching of the bottom electrodes and pillars. Then, the samples were fully covered with SiO$_2$ for insulation. After etching, a series of vias were produced over the pillars to ensure the connection between the junction and the top electrodes. Both the bottom electrodes and tunnel junctions were then connected to 90-nm Ti/Au electrodes using e-beam evaporation to allow electrical contact for the measurements.
**Characterization and measurement:** The magnetic properties were measured by the MOKE (NanoMOKE3, Durham Magneto optics ltd) with a homemade heat source and a VSM (7400, Lakeshore) at different temperatures. The Au/VO$_2$/Au tunnel junctions were measured by normal 4-terminal methods with Keithley 6221 and Keithley 2182 source and measurements units, respectively. HRTEM was performed by a Talos F200X instrument. The XPS results were obtained by a Thermo Fisher ESCALAB 250Xi instrument, and the XRD measurements were performed by a Delta-X instrument.

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**Author contributions**

Declaration of Interests: The authors declare no competing interests.

References and Notes


Figures and Tables

Figure 1. Atomically-thin VO₂ and magnetic heterostructures.
(A) X-ray photoelectron spectroscopy (XPS) profile of the sample with peak fitting results. The proportion of VO₂ reaches 97%.
(B) I-V curve of the VO₂ tunnel junction measured at different temperatures with the current flowing vertically through the device. The insert gives the schematic of the device which is fabricated based on Au/VO₂ (2 nm)/Au heterostructures with a diameter of 10 μm.
(C) The resistance change ratios versus temperature of 2-nm- and 40-nm-thick VO₂ films with a current of 10 nA, which indicate the existence of metal-insulator transition. The resistance change ratio is defined as the temperature dependent resistance divided by its minimum value.
(D) The schematic of the [Pt/Co]₂/VO₂/[Co/Pt]₂ heterostructures.
(E) High-resolution transmission electron microscopy (HRTEM) image of the [Pt/Co]₂/VO₂ (2.26 nm)/[Co/Pt]₂ sample with distinct interfaces.
(F) Schematic diagram of the spinterface-tailored interlayer exchange coupling (IEC) effect. The insulator to metal transition of VO₂ spinterface can enhance the electron density of 3d orbitals near Fermi surface, which may induce the evolution of the interlayer exchange coupling (IEC).
Figure 2. Magnetic properties of [Pt/Co]/VO2/[Co/Pt] heterostructures. 
(A) Hysteresis loops of the [Pt/Co]/VO2 (0.76 nm)/[Co/Pt] sample measured by vibrating sample magnetometer (VSM) at room temperature with magnetic field applied in-plane (red line, step size 200 Oe) and out-of-plane (blue line, step size 2 Oe), where $M$ is the magnetization of the magnetic layers; $M_s$ is the saturation magnetization, $H$ is the external magnetic field. 
(B)-(E) Hysteresis loops of the heterostructure samples measured by polar magneto-optic Kerr microscope (p-MOKE, measurement frequency 0.1 Hz) with VO2 at insulating state (IS, 300 K, black line) and metallic state (MS, 360 K, red line), where the thickness of VO2 spacer is 0.76, 1.48, 1.83 and 2.26 nm, respectively. The two magnetization flips merge into one after the insulator to metal transition. 
(F) In-plane hysteresis loops of the [Pt/Co]/VO2 (0.76 nm)/[Co/Pt] sample at different temperatures measured by VSM (step size 100 Oe), which show no indication of anisotropy change in the metal-insulator transition. The inset gives the enlarged image from -1000 to 1000 Oe.
Figure 3. Regulation of IEC during metal-insulator transition process.
(A) Minor loops of [Pt/Co]_2/VO_2 (0.76 nm)/[Co/Pt]_2 sample obtained by VSM in the magnetic field range of ±3 Oe with a step of 0.1 Oe.
(B) Magnetic domain switching behavior of the sample around the minor loop field range obtained from Kerr microscope with out-of-plane field applied. The center deviation of minor loop indicates the existence of an AFM coupling.
(C) The variation of hysteresis loops measured by VSM (step size 0.5 Oe) at different temperatures for [Pt/Co]_2/VO_2/[Co/Pt]_2 samples with VO_2 of 0.76, 1.48, 1.83, 2.26 nm respectively. The loop features a smooth flip of the top FM layer before a sudden transition into one single flip, and the critical temperatures of IEC type change show obvious difference.
(D) The comparison of the hysteresis loops during heating-up and cooling-down process at 305 K and 315 K. The sharpness of the flip in both results shows a clear difference which is consistent with VO_2 hysteresis feature.
Figure 4. Mechanism of spinterface-tailored IEC via metal-insulator transition.
(A) Exchange bias field of bottom magnetic layer ($H_{ex-bottom}$) versus temperature for 0.76, 1.48, 1.83 and 2.26 nm VO$_2$, respectively.
(B) Thickness dependence of coupling strength obtained from experiment ($J_{exp}$) and calculation ($J_{cal}$) with insulating (at 200 K) and metallic (at 360 K) VO$_2$ spinterface, respectively. The solid blue line is a fitting curve according to the spin dependent tunneling theory with parameters of barrier height 1 eV, effective mass of $m_{eff}=1m_e$. The solid red line is a fitting curve following the RKKY theory with $k_F=1.4*10^7$ m$^{-1}$. Right Y axis has been broken from -25 to 25 μerg/cm$^3$. The inset gives the IEC oscillation calculated from the RKKY model over broad range of VO$_2$ thickness, which indicates the characteristics of an extremely large oscillation period (up to hundreds of nanometers).
(C) Schematic diagram of the IEC regulation mechanism. The inner image gives the energy band variation of VO$_2$ and corresponding coupling mechanism before and after the insulator to metal transition. The spectral weight transfer from $\pi^*$ ($d_{xy}$) orbitals into the valence $d_{\parallel}$ ($d_{xz, yz}$) orbitals enhances the electron density near Fermi surface, and makes coupling mechanism change from the spin dependent tunneling to RKKY interaction. The outside gives the different
spin dynamic evolution process with uniform (left arrow) and non-uniform (right arrow) phase change. For the non-uniform phase change, the electric domain in VO$_2$ may induce local magnetic domain switching during the metal-insulator transition.

(D) The magnetic domain morphology of 0.76-nm-thick VO$_2$ film observed by Kerr microscope at different temperatures with an applied field of 2.6 Oe.